



Appl. No. 10/621,497
Preliminary Amdt. Dated January 14, 2005
Reply to Office action of N/A

JPW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Appl. No. : 10/621,497
Applicant : Tetsuhiro Iwai et al.
Filed : July 17, 2003
Title : PLASMA PROCESSING APPARATUS AND PLASMA
PROCESSING METHOD

Conf. No. : 2610
TC/A.U. : 1724
Examiner : TBD

Customer No. : 000,116
Docket No. : 35908

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

PRELIMINARY AMENDMENT "A"

Sir,

Please amend the above-identified application, prior to examination thereof, in the following manner.

Amendments to the Drawings begin on page 2 of this paper and include both an attached replacement sheet and an annotated sheet showing changes.

Remarks/Arguments begin on page 3 of this paper.

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on the date indicated below.

Aaron A. Fishman

Name of Attorney for Applicant(s)

January 14, 2005

Signature of Attorney/Date